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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Eigo KAWAKAMI et al.

Application No.: 09/577,608

Filed: May 25, 2000

For: POSITIONING APPARATUS, ATMOSPHERE
SUBSTITUTING METHOD, EXPOSURE
APPARATUS, AND DEVICE MANUFACTURING
METHOD

U.S. Patent No. 6,990,173 B1

Issued: January 24, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Attention: Certificate of Correction Branch

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) Examiner: C. E. Church
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) Group Art Unit: 2882
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LETTER CALLING ATTENTION TO ERRORS IN PATENT

Sir:

Patentees note the following errors in the above-identified patent:

COLUMN 1:

Line 15, “device.” should read -- devices. --.

COLUMN 5:

Line 43, “close” should read -- closed --.

COLUMN 8:

Line 31, "manufactures" should read -- manufacture, --.

COLUMN 11:


Line 3, "a" should be deleted.

These errors are relatively insignificant. Therefore, Patentees believe that filing a Request for Certificate of Correction is not warranted. Rather, Patentees request that this paper be placed of record in the official file of the subject patent.

Patentees believe no fee is due for filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed required.

Patentees' undersigned attorney may be reached in our Washington, D.C. Office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,



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